



I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage, as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231, on MAY 20,

TER**IS**E J. WELCH

PATENT APPLICATION IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE APPLICATION OF SHIN UTSUNOMIYA, ET AL.

DOCKET NO.: KOGYO-7

SERIAL NO.: 09/761,025

EXAMINER: MCCLENDON

FILED: JANUARY 16, 2001

ART UNIT: 1711

TITLE: POLYMER COMPOUND, METHOD OF PRODUCING THE SAME

MACUELNELL TON THE STAN TON THE STAN TON THE STAN TON THE STAN THE PHOTOSENSITIVE COMPOSITION, AND PATTERN FORMATION

METHOD

WILMINGTON, DE DATE: MAY 20, 2002

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action dated March 11, 2002, the applicants elect to prosecute Group I, Claims 1 through 4, at this time. If any issues remain, the Examiner is urged to contact the undersigned to expedite their resolution.

Respectfully submitted.

Attorney for Applicants

Registration No. 44,718

Telephon (2) 426-0610

justcent date: 11/13/2002 ASELLMAN 16/2002 ASELLMAN 00000004 083440 09761025 01 FC:116 400.00 CR

L:\clients\Kurihara\Kogyo-7\documents\Restriction.1.doc